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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: Application of

**ATTN: Office of Initial Patent
Examinations**

Takaei SASAKI, et al.

Application No.: 10/706,944

Attorney Dkt. No.: 101136-00103

Filed: November 14, 2003

Confirmation No.: 7420

For: METHOD AND APPARATUS FOR DRY-ETCHING HALF-TONE PHASE-SHIFT FILMS,
HALF-TONE PHASE-SHIFT PHOTOMASKS AND METHOD FOR THE
PREPARATION THEREOF, AND SEMICONDUCTOR CIRCUITS AND METHOD FOR
THE FABRICATION THEREOF

REQUEST TO ADD CUSTOMER NUMBER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: August 12, 2004

Sir:

It is respectfully requested that the records of the U.S. Patent and Trademark Office be updated for the above-identified patent application to be associated with and indicate Customer Number **004372**.

In the event that any fees are due with respect to this paper, please charge Deposit Account No. 01-2300, referencing Atty Docket No. 101136-00103.

Respectfully submitted,

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APPLICATION NUMBER	FILING OR 371 (c) DATE	FIRST NAMED APPLICANT	ATTY. DOCKET NO.
10/706,944	11/14/2003	Takaei Sasaki	101136-00103

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CONFIRMATION NO. 7420



OC000000012722728

Title: Method and apparatus for dry-etching half-tone phase-shift films, half-tone phase-shift photomasks and method for the preparation thereof, and semiconductor circuits and method for the fabrication thereof

Publication No. US-2004-0094504-A1
Publication Date: 05/20/2004

NOTICE OF PUBLICATION OF APPLICATION

The above-identified application will be electronically published as a patent application publication pursuant to 37 CFR 1.211, et seq. The patent application publication number and publication date are set forth above.

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